

PATENT

Attorney Docket No.: SAM-0526

Customer No.: 29344

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

Ki Hwan Park, et al.

Examiner:

El Arini, Zeinab

Serial No.:

10/796,507

Group Art Unit:

1746

Filing Date:

March 9, 2004

Title:

METHOD OF RINSING AND DRYING SEMICONDUCTOR

SUBSTRATES (As Amended)

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited with the United States Post Office as First Class Mail in an envelope addressed to the Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

TRANSMITTAL LETTER

Sir:

Enclosed herewith for filing in the above-identified patent application please find the following listed items:

- Amendment Transmittal; 1.
- Amendment After Final Rejection in response to Office Action mailed on February 16, 2. 2006; and
- Return Postcard 3.

In connection with the foregoing matter, please charge any additional fees which may be due, or credit any overpayment, to Deposit Account Number 50-1798. A duplicate copy of this letter is provided for this purpose.

Respectfully submitted,

Date: Laul 12,2006 Mills & Onello LLP

Eleven Beacon Street, Suite 605

Boston, MA 02108

Telephone: (617) 994-4900 Facsimile: (617) 742-7774 J:\SAM\0526\AAF\transamendafterfinal.wpd Anthony P. Onello, Jr.

Registration Number 38,572

Attorney for Applicant



PATENT Attorney Docket No.: SAM-0526

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic Serial I Filing Title:	No.:	Ki Hwan Park, et al. 10/796,507 March 9, 2004 METHOD OF RINSING AN SUBSTRATES (As Amendo		El Arini, Zeinab 1746 CONDUCTOR
addressed	I hereby coto the Mail	CERTIFICATE OF MAILING entify that this correspondence is being deposited with Stop AF, Commissioner for Patents, P.O. Box 1450, 14-112-106	the United States Post Office a	s First Class Mail in an envelope
		Date	Christina Harris	
Comm P.O. B	ox 1450	for Patents rginia 22313-1450		
		AMENDMENT TE	RANSMITTAL	
Sir:				
1.	Transn	nitted herewith is an amendment for	this application.	
		STATI	<u>US</u>	
2.	Applic	ant is		
		a small entity.		
	⊠	other than small entity.		
		EXTENSION	OF TERM	
3. apply.	The pro	oceedings herein are for a patent app	lication and the provi	sions of 37 CFR 1.136
(a)	□ Ap	plicant petitions for an extension of t	ime under 37 CFR 1.	136

Applicant(s):	Ki Hwan Park,	et al.
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Serial No.: 10/796,507

Fee for other than	Fee for
small entity	small entity
\$120.00	\$60.00
\$450.00	\$225.00
\$1,020.00	\$510.00
\$1,590.00	\$795.00
	small entity \$120.00 \$450.00 \$1,020.00

Fee \$ ____

If an additional extension of time is required, please consider this a petition therefor.

☐ An extension for ___ months has already been secured and the fee paid therefor of \$___ is deducted from the total fee due for the total months of extension now requested.

Extension fee due with this request \$ _____

OR

(b) Applicant believes that no extension of term is required. However, this conditional petition is being made to provide for the possibility that applicant has inadvertently overlooked the need for a petition for extension of time.

FEE FOR CLAIMS

4. The fee for claims (37 CFR 1.16(b)-(d)) has been calculated as shown below:

	CLAIM	S AS AME	NDED			
	(1)		(2)	(3)		
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR	PRESENT NUMBER EXTRA	RATE	FEE
TOTAL CLAIMS	13	minus	38	0	x \$50	\$0
INDEPENDENT CLAIMS	1	minus	4	0	x \$200	\$0
MULTIPLE DEPENDENT CLAIM ADDED	No				\$360	
			10 - 10	то	TAL	\$0
If applicant has small entity status under 37 CFR 1.9 and 1.27, then divide total fee by 2 and enter amount here.				SMALL ENTITY TOTAL		

Applic Serial		s): Ki Hwan Park, <i>et al.</i> 10/796,507	
(c)	×	No additional fee for claims is required.	
		OR	
(d)		Total additional fee for claims required S	\$
		FEE PAYN	<u>MENT</u>
5.		Attached is a check in the sum of \$ Charge Deposit Account No A duplicate of this transmittal is attached	
			Respectfully submitted,
Eleven Bostor	& Ói Bea n, M	Jail 17, 1006 nello LLP acon Street, Suite 605 A 02108 : (617) 994-4900	Anthony P. Onello, Jr. Registration Number 38,572 Attorney for Applicant

Facsimile: (617) 742-7774 J:\SAM\0526\AAF\amendafterfinaltrans.wpd



Attorney Docket No.: SAM-0526 Application Serial No.: 10/796,507 Reply to Office Action of: February 16, 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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04/12/06

Christina Harris

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

The following is in response to the Office Action dated February 16, 2006, and is filed within the shortened statutory period of three months. Please amend the application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.